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Substitute for form 1449A/B/PTO				Complete if Known Application Number 10/533143 Filing Date Herewith First Named Inventor Seiji Sugiura Art Unit Not Yet Assigned Examiner Name Not Yet Assigned Attorney Docket Number TOW-099US	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)					
Sheet	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
/K.H.	A1	5,998,055	12-07-1999	Kurita, et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	A2	EP 0 459 940 A1	12-04-1991	Institute of Gas Technology		
	A3	JP 9-130107	07-30-1999	Institute of Gas Technology		
	A4	WO 92/04740 A1	03-19-1992	Allied-Signal Inc.		
	A5	JP 6-582857	08-31-1994	Allied-Signal Inc.		
/K.H.	A6	JP 6-163063	06-10-1994	Institute of Gas Technology		abst
	A7	JP 08-222237	08-30-1996	Aisin AW Co. Ltd.		abst
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/K.H.	A11	JP 2000-164230	06-16-2000	Aisin Seiki Co. Ltd.		
	A12	JP 2000-320440	11-24-2000	Mitsubishi Heavy Ind. Ltd.		
	A13	JP 2002-330030	03-17-2002	Institute of Gas Technology		

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

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Examiner Signature	/Kwang Han/ (05/21/2008)	Date Considered	05/21/2008
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /K.H./